

85A 3050

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

SHIGERU HAYATA et al.

Serial No: 09/800,323

Filed: March 6, 2001

For: OFFSET MEASUREMENT
METHOD, TOOL POSITION
DETECTION METHOD AND
BONDING APPARATUS

Art Unit: 2877

Examiner: Hoa Q. Pham

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OFFICIALRULE 116 AMENDMENTCommissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Dear Sir:

In response to the Final Office Action dated January 2, 2004, please amend the
above-identified application as follows: